Electronic Acknowledgement Receipt				
EFS ID:	1365788			
Application Number:	09759715			
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Title of Invention:	SEMICONDUCTOR DEVICES AND METHODS FOR MANUFACTURING THE SAME			
First Named Inventor/Applicant Name:	Hiroaki Tsugane			
Correspondence Address:	Konrad, Raynes & Victor, LLP Suite 210 315 South Beverly Drive - Beverly Hills CA 90212 US 3105567983 -			
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part /.zip	Pages (if appl.)	
1	Miscellaneous Incoming Letter	T_Cert_Corr.pdf	53266	no	2	
Warnings:						
Information:						
2	Request for Certificate of Correction	sb0044_fill.pdf	22818	no	1	
Warnings:						
Information:						
	Total Files Size (in bytes)		76084			

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New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.